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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Manabu IWAMOTO, *et al.*
U.S. Serial No. : To be Assigned
Filing Date : Filed Concurrently Herewith
International Appln. No. : PCT/JP03/15552
International Filing Date : December 4, 2003 (Priority Date: 10 December 2002)
Title of Invention : **METHOD OF CALCULATING STENCIL MATERIAL
ROLL RESIDUE, STENCIL MAKING SYSTEM AND
STENCIL MATERIAL ROLL**

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PRELIMINARY AMENDMENT

Mail Stop PCT (DO/EO/US)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination kindly amend the application, without prejudice, as follows.

IN THE TITLE:

Please enter this application with the title as shown above. The translation of the title as shown in PCT Publication No. WO/2004/052653 was done at the IB, and our Japanese associate and translator has indicated that this title is not accurate. According to our Japanese associate and translator, this invention concerns "stencil material and a stencil making system" rather than a "mimeograph paper roll and mimeograph plate making apparatus" as has been translated in the Publication. The title as it appears in the English translation of the